

Notice of References Cited	Application/Control No. 10/735,704	Applicant(s)/Patent Under Reexamination KOIKE ET AL.	
	Examiner Thomas M. Dougherty	Art Unit 2834	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Micro-Metrics Co. H-501 Pencil Hardness Gage, pages 1-3, Micro--Metrics Company, Atlanta GA. 30324-0804.
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